



IFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki NAGASAKA

Group Art Unit: 2851

Application No.: 10/589,962

Examiner: C. RIDDLE

Filed: August 18, 2006

Docket No.: 128675

For: EXPOSURE METHOD, EXPOSURE APPARATUS, EXPOSURE SYSTEM AND
DEVICE MANUFACTURING METHOD

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the February 13, 2009 Office Action, and the May 5, 2009 personal
interview, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.